<u>S/N 10/681,481</u> <u>PATENT</u>

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Paul A. Farrar

Examiner: Nicole Blan

Serial No.:

10/681,481

Group Art Unit: 1792

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Title:

METHOD OF CLEANING SEMICONDUCTOR SURFACES

## AMENDMENT & RESPONSE UNDER 37 C.F.R. § 1.111

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In response to the Office Action mailed March 12, 2009, please amend the application as follows: